

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. MASUDA, et al

Serial No.: 09/421,043

Filed: October 20, 1999

For: PLASMA ETCHING APPARATUS AND PLASMA ETCHING
METHOD

Group: 1763

Examiner: A. Mulero

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PETITION FOR EXTENSION OF TIME

Commissioner of Patents
Washington, D.C. 20231

February 19, 2002

Sir:

In the matter of the above-identified application, applicant(s) hereby respectfully petition for an extension of time to permit filing of a response within the first month subsequent to the shortened statutory period set in the outstanding Office Action mailed October 23, 2001. A payment in the amount of \$110.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (503.34403CV4).

Respectfully submitted,



Melvin Kraus
Registration No. 22,466
ANTONELLI, TERRY, STOUT & KRAUS, LLP

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